

10/590037

IAP12 Rec'd PCT/PTO-1 8 AUG 2006

PTO/SB/08a/b (07-05)

Approved for use through 07/31/2006. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known	
				Application Number	Not Yet Assigned
				Filing Date	Concurrently Herewith
				First Named Inventor	Anja Gerhard
				Art Unit	N/A
				Examiner Name	Not Yet Assigned
Sheet	1	of	1	Attorney Docket Number	14113-00043-US

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
/MHW	BA	EP-0 786 926	07-30-1997	Toyo Ink Manufacturing Co., Ltd.		
	BB	JP-2003-123973	04-25-2003	Canon KK		See Abstract
	BC	JP-2003-123972	04-25-2003	Canon KK		See Abstract
	BD	EP-1 318 143	06-11-2003	Shozo Yanagida et al.		
	BE	WO-03/104245	12-18-2003	Ciba Specialty Chemicals Holding Inc.		
	BF	JP-2004-095221	03-25-2004	Toray Industries		See Abstract
	BG	EP-1 426 429	06-09-2004	Canon Kabushiki Kaisha		
	BH	WO-2004/093207	10-28-2004	Covion Organic Semiconductors GmbH		See Abstract
	BI	WO-2005/003253	01-13-2005	Covion Organic Semiconductors GmbH		See Abstract
	BJ	WO-2005/040302	05-06-2005	Covion Organic Semiconductors GmbH		See Abstract
	BK	WO-2005/054403	06-16-2005	Covion Organic Semiconductors GmbH		See Abstract

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

Examiner Signature	/Michael H. Wilson/	Date Considered	09/24/2008
-----------------------	---------------------	--------------------	------------

481124